

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 4090

Kazuto HIROKAWA et al. : Attorney Docket No. 2003_0960A

Serial No. 10/617,789 : Group Art Unit 3723

Filed July 14, 2003 : Examiner Hadi Shakeri

SUBSTRATE POLISHING APPARATUS: Mail Stop: Amendment

<u>AMENDMENT</u>

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action of December 20, 2005, please amend the above-identified U.S. Patent application as follows: